

Search Notes 	Application/Control No.	Applicant(s)/Patent under Reexamination
	09/850,195	THEKKATH ET AL.
	Examiner	Art Unit
	Gabriel L. Chu	2114

SEARCH NOTES (INCLUDING SEARCH STRATEGY)		
	DATE	EXMR
714 30,726,727 updated	1/5	rc
Scott Baderman	1/5	rc
ACM: ejtag	1/5	rc
IEEE: ejtag, dmseg, pracc,	1/5	rc
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